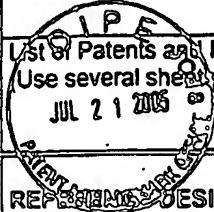


Form PTO-1449 (Modified)		Atty Docket No.: P18237		Serial No.: 10/829,592			
<div style="float: left; width: 150px; text-align: center;">  </div> List of Patents and Publications Statement Use several sheets if necessary)				Applicant: Michael D. Goodner et al.			
				Filing Date: April 21, 2004			
REFERENCES DESIGNATION			U.S. PATENT DOCUMENTS				
Examiner Initials	AA	Document No.	Quek et al. 20/2001	Class	Sub-Class	Filing date if appropriate	
<i>JA</i>	AB	6,252,290 B1	Meagley et al. 12/2004	257	522	X	
<i>JA</i>	AC	6,833,320 B2	Morrow et al. 11/2002	438	640		
<i>JA</i>	AD	2002/0175417 A1	Babich et al. 10/2002	257	758		
<i>JA</i>	AE	2002/0158337 A1		257	758		
	AF						
	AG						
	AH						
FOREIGN PATENT DOCUMENTS							
No.	AI	Document No.	Date	Country	Class	Sub-Class	Translation
<i>JA</i>	AJ	102 38 024 A1	3/11/2004	Germany	H01L	21/768	
	AK						
OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)							
<i>JA</i>	AL	Robert P. Meagley et al., "Photodefinable Polymers for Semiconductor Applications", Serial No. 10/337,575, Filed January 6, 2003.					
	AM	Robert P. Meagley et al., "Photodefinable Polymers for Semiconductor Applications", Serial No. 10/616,895, Filed July 10, 2003.					
	AN	Andrew W. Ott et al., "Forming a Dielectric Layer Using Porogens", Serial No. 10/394,104, Filed March 21, 2003.					
	AO	Grant M. Kloster et al., "Forming a Porous Dielectric Layer", Serial No. 10/395,447, Filed March 24, 2003.					
	AP	Grant M. Kloster et al., "Forming a Porous Dielectric Layer", Serial No. 10/782,329, Filed February 19, 2004.					
	AQ	Michael D. Goodner, "UV-Activated Dielectric Layer", Serial No. 10/403,532, Filed March 31, 2003.					
	AR	Michael D. Goodner, "UV-Activated Dielectric Layer", Serial No. 11/058,798, Filed February 15, 2005.					
	AS	Robert P. Meagley et al., "Photoactive Resist Capping Layer", Serial No. 10/927,885, Filed August 27, 2004.					
	AT	Robert P. Meagley et al., "Removing Sacrificial Material by Thermal Decomposition", Serial No. 10/953,744, Filed September 29, 2004.					
	AU	Vijayakumar S. RamachandraRao et al., "Post-Deposition Modification of Interlayer Dielectrics", Serial No. 10/609,963, Filed June 30, 2003.					
<i>JA</i>	AV	Robert P. Meagley, "Photoactive Adhesion Promoter", Serial No. 10/288,021, Filed November 4, 2002.					
	AW						
Examiner <i>JA</i>			Date Considered 12/29/05				
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

KS
01/26/07